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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2851
Examiner: Hung Nguyen

In Re PATENT APPLICATION of:

Applicant(s): Ryoichi AOYAMA et al.

Serial No.: 10/748,240

Filing Date: December 31, 2003

For: SELF-CLEANING METHOD FOR
SEMICONDUCTOR EXPOSURE
APPARATUS

Atty. Dkt.: OKI 395

AMENDMENT

April 4, 2005

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on January 5, 2005, please
amend the above-identified application as follows:

FEE ENCLOSED:\$
Please charge any further
fee to our Deposit Account
No. 18-0002